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SHEET 1 OF 1

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT									IAL NO. <b>7591,597</b>		
						APPLICANT Tohru YAMAOKA, et al.					
(Substitute for form 1449/PTO)						FILING DATE September 05, 2006			ROUP <b>614</b>	<del>-</del>	
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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.